 	notes	•.

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/531,245	SENKEVICH ET AL.	
Examiner	Art Unit	
SEVED MASOUD	1722	

MALEKZADEH

SEARCHED				
Class	Subclass	Date	Examiner	
117	84	2/1/2007	SMM	
117	88	2/1/2007	SMM	
117	89	2/1/2007	SMM	
117	99	2/1/2007	SMM	
117	102	2/2/2007	SMM	
117	104	2/2/2007	SMM	
117	105	2/2/2007	SMM	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		,		

SEARCH NOT (INCLUDING SEARCH S		)
	DATE	EXMR
Use Palm Intranet to search inventor's name	2/1/2007	SMM
Use text search through East to find prior art. Examiner used key words such as " Atomic Layer Deposition"	2/1/2007	SMM
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